AMENDMENT TRANSMITTAL LETTER (Small Entity) Applicant(s): Young-Hoon Park							Docket No. YPI0017
Serial No. 09/848,577		Filing Date 5-3-2001		Examiner Moore, Karla A.		Group Art Unit 1763	
Invention: REACTOR FOR DEPOSITING THIN FILM ON WAFER							
TO THE COMMISSIONER FOR PATENTS:							
Transmitted herewith is an amendment in the above-identified application.  Small Entity status of this application has been established under 37 CFR 1.27 by a verified statement previously submitted.  A verified statement to establish Small Entity status under 37 FR 1.27 is enclosed.  The fee has been calculated and is transmitted as shown below.							
CLAIMS AS AMENDED							
		S REMAINING AMENDMENT	HIGHEST #		BER EXTRA S PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20	) -	20 =		0	x \$9.	00 \$0.00
INDEP, CLAIMS	1		3 =		0	x \$43	.00 \$0.00
Multiple Dependent Claims (check if applicable)							\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT							\$0.00
No additional fee is required for amendment.  Please charge Deposit Account No. in the amount of  A check in the amount of to cover the filing fee is enclosed.  The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 06-1130  Any additional filing fees required under 37 C.F.R. 1.16.  Any patent application processing fees under 37 CFR 1.17.  Dated: January 6, 2004							
Reg. No. (PLEAS) Confirmation No Confor Colburn 55 Griffin Road S Bloomfield, CT 0 PTO Customer N (860) 286-2929	. 6816 LLP South 6002	ITACHED)			on first class mai Commissione 22313-1450.	il under 37 C or for Patents	nent and foe is being deposited with the U.S. Postal Service as E.F.R. 1.8 and is addressed to the P.O. Box 1450, Alexandria, VA in Mailing Correspondence